

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q63075

Kazunobu FUJIKAWA, et al.

Appln. No.: 09/763,194

Group Art Unit: 3742

Confirmation No.: 3832

Examiner: Maria Alexandra ELVE

Filed: February 20, 2001

For: METHOD AND APPARATUS FOR SURFACE DISCHARGE PROCESSING , AND AN  
ELECTRODE FOR SURFACE DISCHARGE PROCESSING

**RESPONSE UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated February 2, 2009, please consider the remarks as  
submitted herewith on the accompanying pages.